



# The challenges in understanding CIGS thin film cell and module reliability

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# Discussion topics

- **PVMC – Introduction**
- **CIGS Device reliability-** Failure modes/Mechanisms
  - Device/Unit film metrology,, TCO engineering
- **Module level reliability**
  - Field failures- Failure modes
  - Indoor Accelerated Lifetime Tests
  - Select examples-Failure mechanisms
    - Combinatorial stress
    - Interconnect
- **System level failures**
  - Modeling
- **Integrated database**
- **Challenges and opportunities summarized**

# The U.S. Photovoltaic Manufacturing Consortium – Program Overview

- Manufacturing scale research through industry led consortium for collaborative and proprietary activities at a pilot line and manufacturing development facility
- Overall investment of \$300 M over 5 years from DOE, Industry, NY State.
- Focus on leading thin film solar PV technology – and manufacturing methods
- Expertise of primary partners – SEMATECH, CNSE – in consortium management, technology development, manufacturing productivity, and workforce development
- Breadth of support – partnership with ~60 companies and organizations throughout thin film PV industry supply chain



DOE

CNSE

SEMATECH

INDUSTRY



# Strategic Objectives of PVMC

Establishing Roadmaps and Standards

Establishing Thin Film Manufacturing Development Facility

- Access to 100 kW line
- Front End and Back End of 10 MW
- (Flexible and Rigid Line)

Thin Film Manufacturing Scale-up

- Best Practices and Cost Modeling
- Productivity, Effectiveness and Manufacturing Quality

Thin Film Commercialization Support

- Deployment, Licensing, Attraction, Incubation

Developing Highly Trained Workforce

## TWG- Technical Working Groups

LPV

Manufacturing scale up  
Industry relevant projects ( LPV)

Metrology

Metrology for Manufacturing  
Performance measurement standards

Field  
Performance

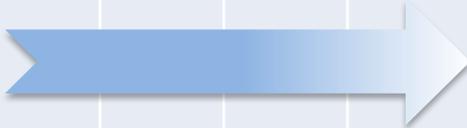
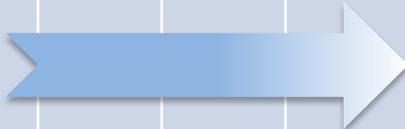
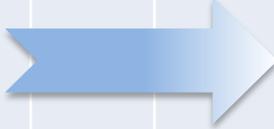
Bankability  
Outdoor performance Monitoring  
Indoor Accelerated Life time tests

**SOLICIT INDUSTRY INPUTS**

**Design Projects**

**Results delivered according to milestones**

# PVMC Multi-Year Strategy: 3 year and beyond

|                              | Yr1   | Yr2   | Yr3   | Yr4   | Yr5 | Partners  | Objectives/Tasks  |
|------------------------------|---|---|---|---|-----|---|---|
| (FEOL) PV Cell Manufacturing |  |   |   |   |     | Equipment/Material Metrology/Suppliers, R&D Companies   | Manufacturing Productivity, Cost Model, Metrology                   |
| (BEOL) Module Manufacturing  |   |  |   |   |     | Equipment/Suppliers, PV and Roofing Manufacturers       | Effectiveness, Life cycle, Reliability, Metrology Testing, Quality, |
| Roof Integration             |   |   |  |   |     | Architects, Installers, Roofers, Contractors, Utilities | Design, Standards, Testing, Installation, Reliability, BOS          |
| LPV Deployment               |   |   |   |  |     | Utilities, Installer, End Users , Building Owners       | Commercialization, Field Test, System Cost, Grid Integration        |

# Current PVMC Members, Research Partners and Supply Partners



# Challenges in CIGS Reliability

## To develop reliable PV modules

Understand potential failure mechanisms driving a failure mode

Reliability of a PV product depends on

- Manufacturing methods

- Types of packaging

  - Flat panel (Glass-Glass)-Monolithic

  - Glass/Backsheet

  - Flexible modules (LPV)

  - CPV

- Used condition (climates)

**Observe failure modes (identify mechanisms) in outdoor PV field**

**Need to wait for 25 years – NOT a solution!**

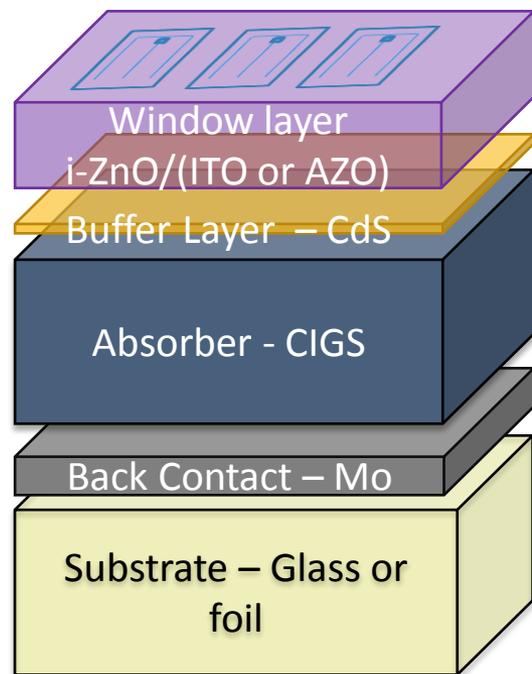
**Develop accelerated stress tests-(and formulate Qualification tests)**

to observe the failure mechanisms in a short period of time

to predict lifetime of the module

CIGS Device reliability  
Associated Failure modes/Mechanisms  
Device/Unit film metrology  
TCO Engineering

# CIGS device stack - Deposition methods and materials

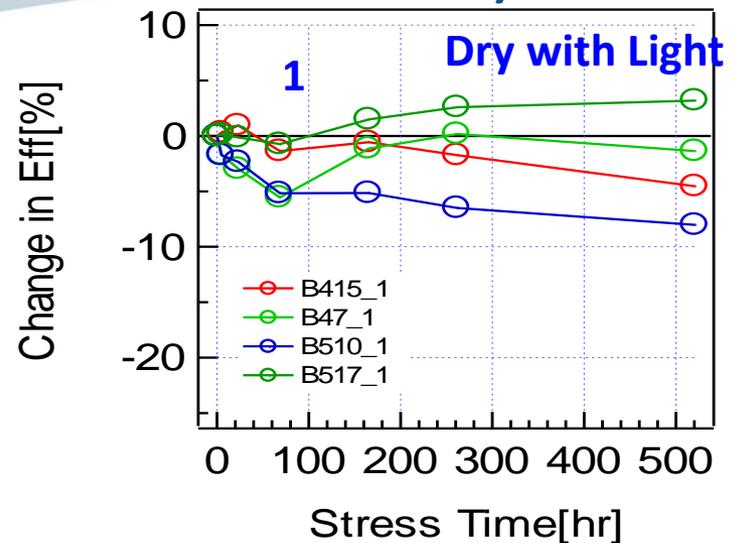


| Co-evaporation example  | Alternatives  |
|---|---|
| <b>Grids: Evaporation</b><br>Ni (150-500Å) Ag (5000-6000Å)<br>Al(2-3μ);                             | <b>Grids/ Screen print/wire overlay/ tab and string diff interconnects</b>              |
| <b>Window layer: Sputter</b><br>Resistive: i-ZnO-0.1-.12μ;<br>Conductive:AZO- 0.1-.15μ              | <b>Window layer: MoCVD</b><br><b>Zno:B; InZnO; ITO</b>                                  |
| <b>Buffer Layer: Chemical bath deposition (CBD)</b><br>CdS, ~20-80nm;                               | <b>Buffer Layer: Chemical bath deposition (CBD)/Sputter:</b><br>Zn(O,S); ~20-80nm;      |
| <b>CIGS: 1stage/2 stage /3 stage</b><br>Cu, In, Ga are co-evaporated in Se overpressure CIGS- ~1-2μ | <b>CIGS: Reactive sputtering, Ink deposition/ coating, Selenization, Co-evaporation</b> |
| <b>Molybdenum-Sputter; ~0.3-1μ</b><br>Barrier layers:Cr/Nitride                                     | <b>Na barrier/ Se barrier/ Oxide barrier</b>  |
| <b>Glass:2mm or 3.2mm</b><br><b>Stainless foil: ~25μ</b>  | <b>Aluminum</b><br><b>Polyimide</b>   |

Deposition methods & Thickness

In-depth analysis using different characterization techniques is required to understand the interfacial properties-Include Na incorporation

# Device efficiency- Moisture and Temperature/Light Effects

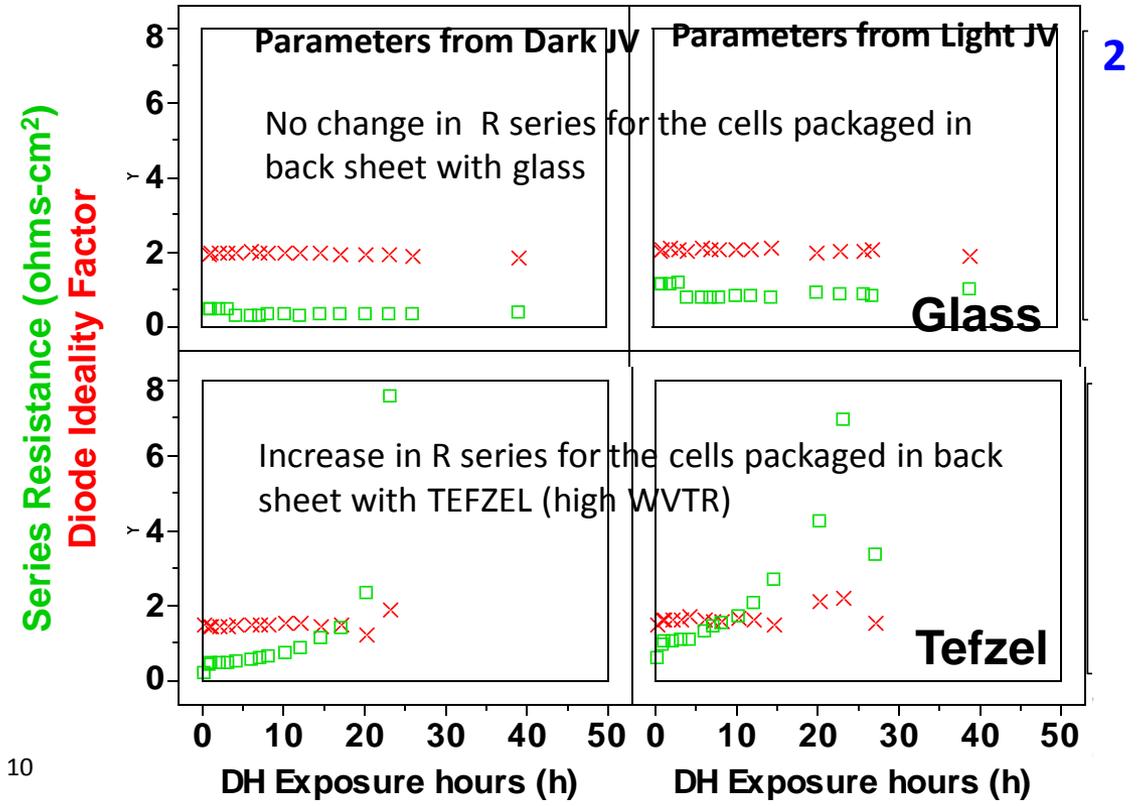
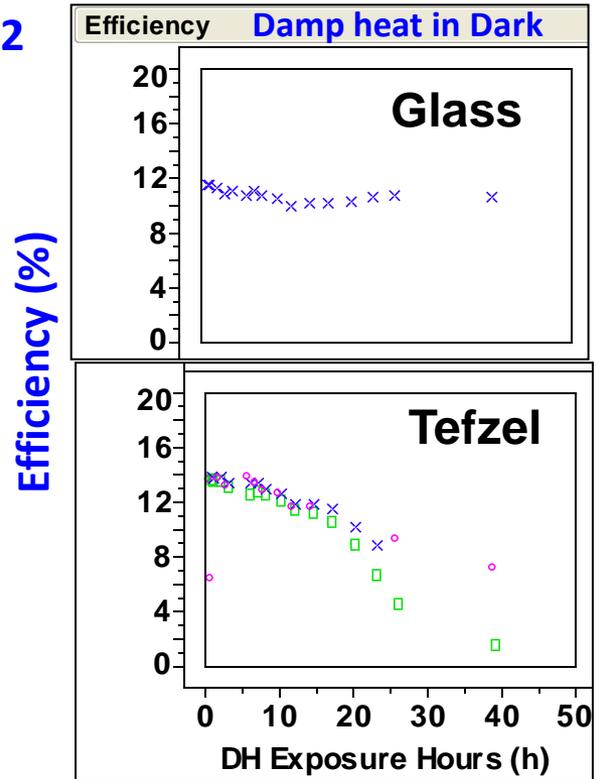


**2) DH Degradation – Efficiency (0-50 hrs)- Encapsulated without EVA**

- ✓ driven by decrease in  $J_{sc}$  & FF >10%
- ✓ Less than 5% decrease in  $V_{oc}$

- 1) CIS Device-Level Stability- D. Albin et.al
- 2) Influence of damp-heat in electrical, optical and morphological properties of encapsulated CIGS devices R.Sundaramoorthy et.al. 37<sup>th</sup> IEEE-PVSC

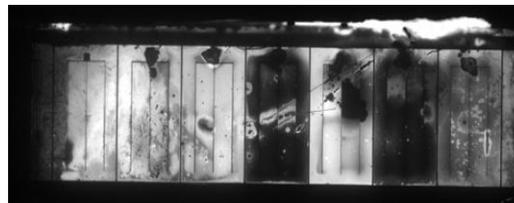
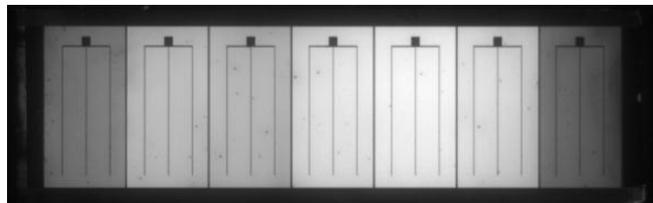
## Modeling of Dark and light JV curves



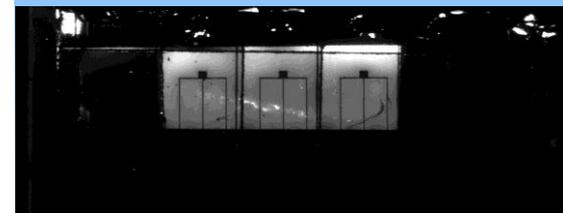
# Recombination and lifetime- correlation

## Before DH

## After DH



PL image after  
**re-fabrication** of the  
DH exposed device



PL- Dark spots indicate increased recombination after DH

Influence of damp-heat in electrical, optical and morphological properties of encapsulated CIGS devices -R.Sundaramoorthy et.al.37<sup>th</sup> IEEE-PVSC

TRPL measurements after DH exposure

| Back sheet             | Lifetime $\tau_1$ (ns) |
|------------------------|------------------------|
| N/A, stored in ambient | 6.25                   |
| Glass                  | 8                      |
| TPAT                   | 8.56                   |
| TPT                    | 8.87                   |
| Tefzel                 | 1.85                   |

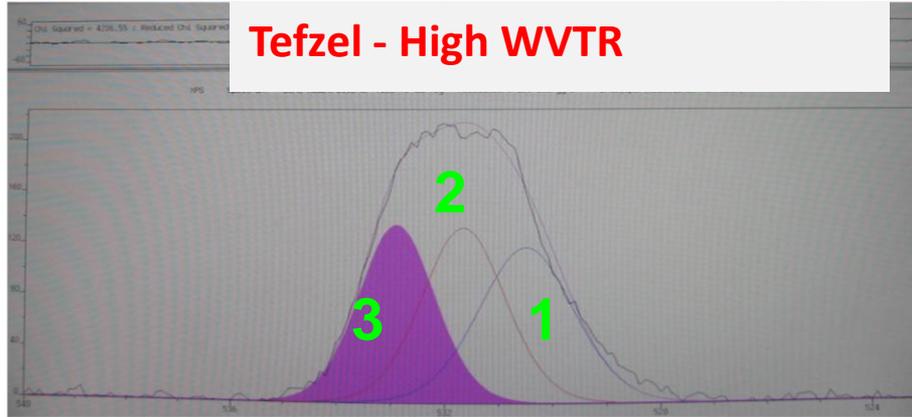
| DH Exposure Time (h)      | $V_{oc}$ (V) | $J_{sc}$ (mA/cm <sup>2</sup> ) | FF (%) | Efficiency (%) |
|---------------------------|--------------|--------------------------------|--------|----------------|
| 0                         | 0.69         | 32.8                           | 78     | 17.7           |
| 1                         | 0.64         | 28.1                           | 58     | 10.4           |
| 784                       | 0.65         | 19.9                           | 59     | 7.6            |
| N/A, after re-fabrication | 0.56         | 28.4                           | 60.9   | 9.68           |

JV parameters before and after DH exposure and re-fabrication indicate absorber is intact; while TCO has degraded.

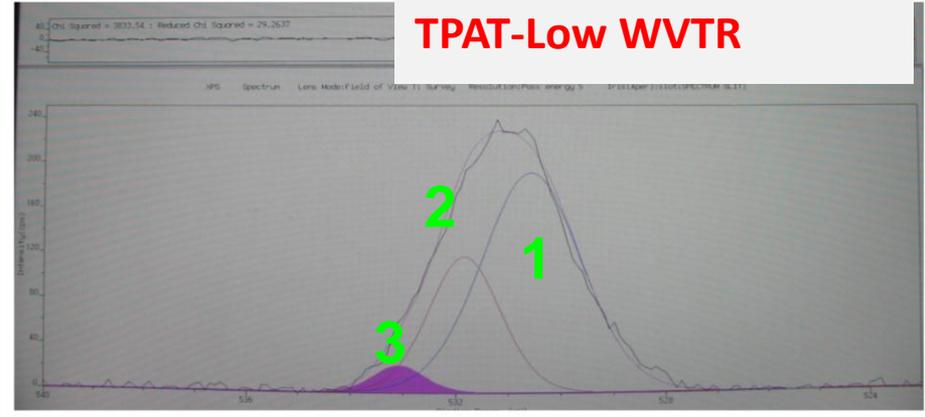
# Material level – Identification of failure mechanisms

## Oxygen 1s core level peak for samples encapsulated in

Tefzel - High WVTR



TPAT-Low WVTR

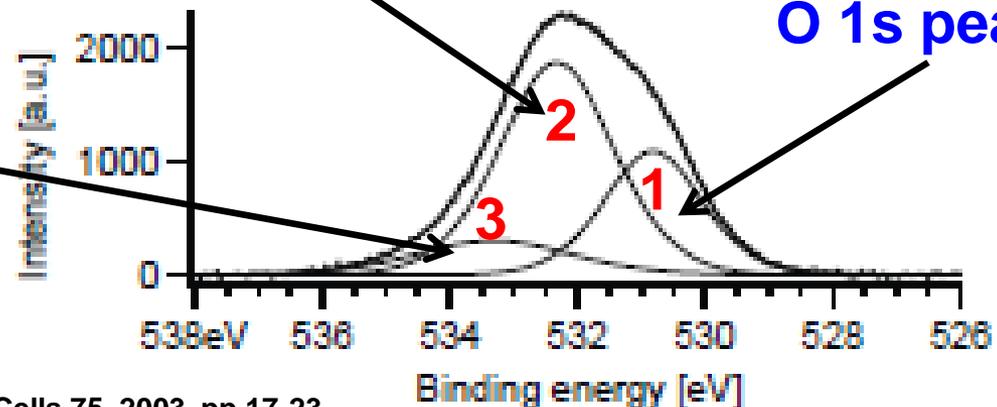


Evidence of hydrolysis of ZnO (TCO) and moisture in TCO (531.5–532.2 eV)  
Formation of  $\text{Zn}(\text{OH})_2$  after DH exposure and moisture trapped in the devices packaged with backsheet having high WVTR

(532.8–534 eV)  
adsorbed water

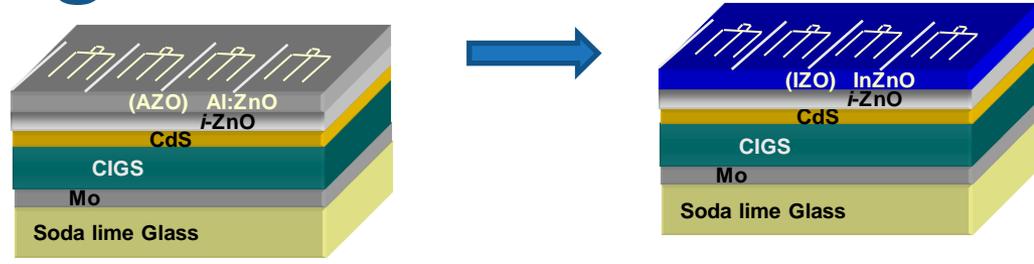
$\text{Zn}(\text{OH})_2$

529.9–530.7 eV  
O 1s peak



# TCO Engineering- device level

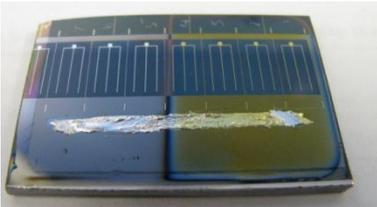
One approach for CIGS devices for improving device performance in DH



- ❖ Alternative TCO which is DH stable IZO (InZnO) for CIGS
  - Conductive layer (i-ZnO/c-InZnO)
  - Bi-layer(i-InZnO/c-InZnO)

❖ Barrier layers on CIGS ( TCOs and PTMO)

Un exposed

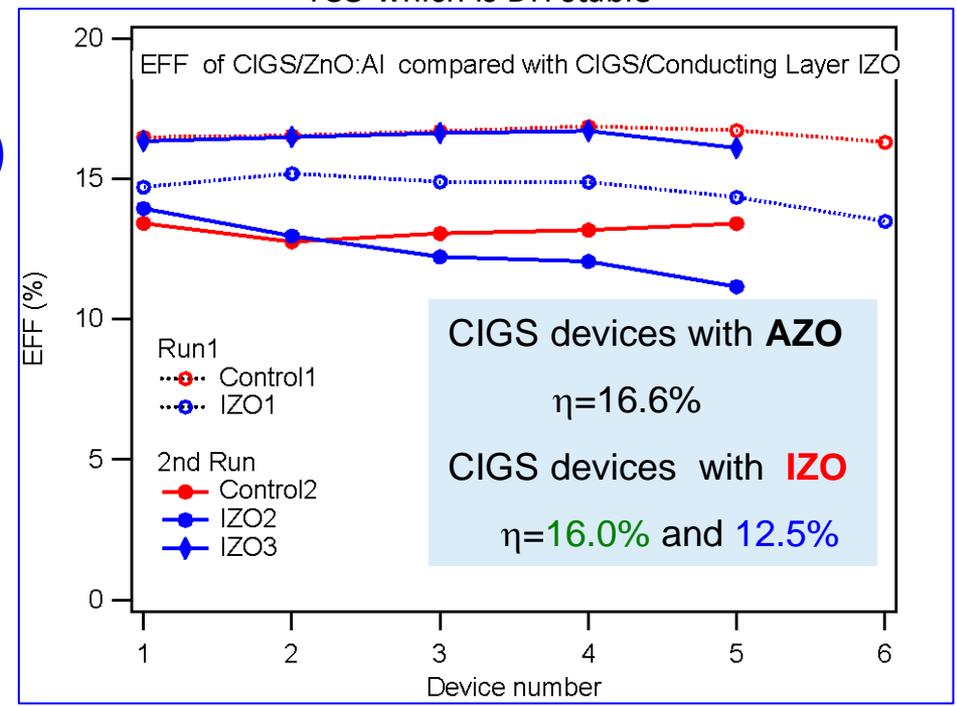


After 38h in DH



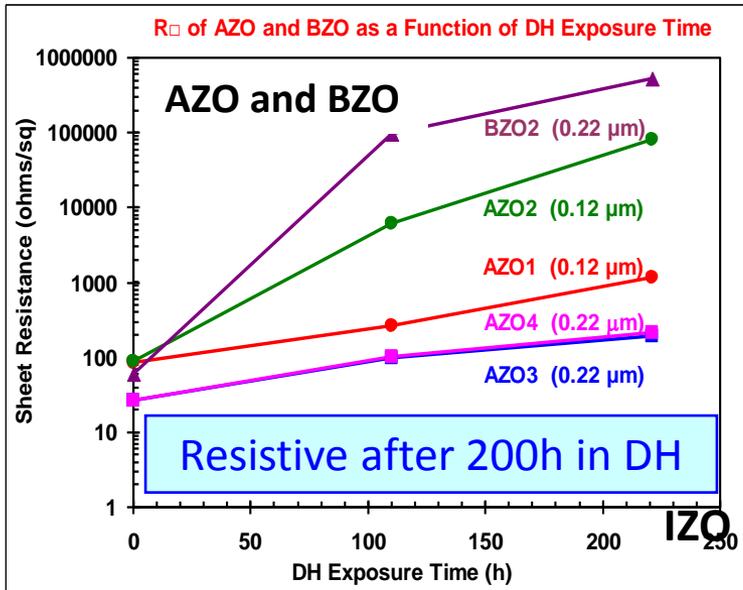
PL Image after DH exposure

R. Sundaramoorthy et.al 34<sup>th</sup> IEEE-PVSC  
Comparable efficiencies with alternative conducting TCO which is DH stable



PTMO protects the CIGS device  
 Extends the life time of the bare device- By how many hrs?  
 How is it related to lifetime during outdoor exposure

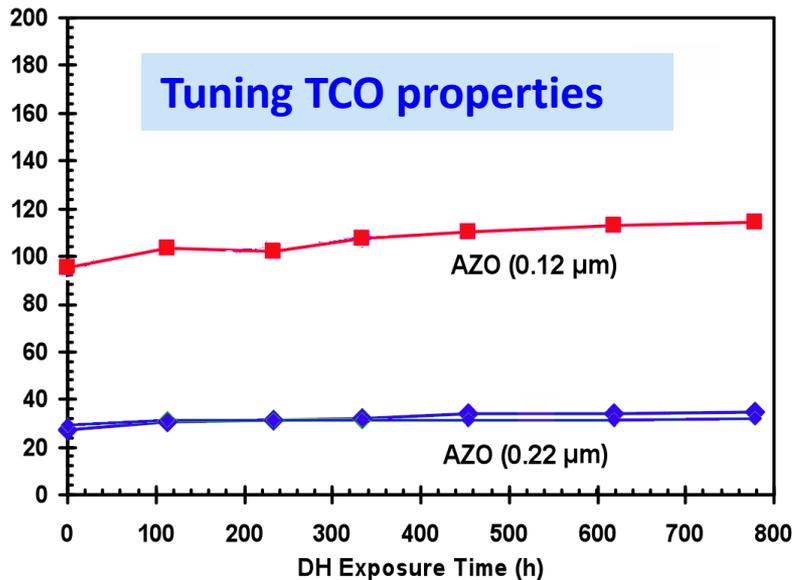
# Unit film Engineering



Order of decreasing stability:

ITO ~ InZnO >> B:ZnO >>> Al:ZnO ~ BZO

- 1) R. Sundaramoorthy et al, SPIE 2010
- 2) Pern et al, SPIE 2011



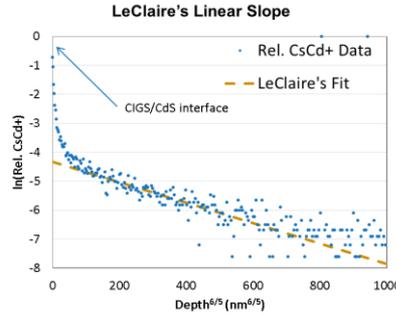
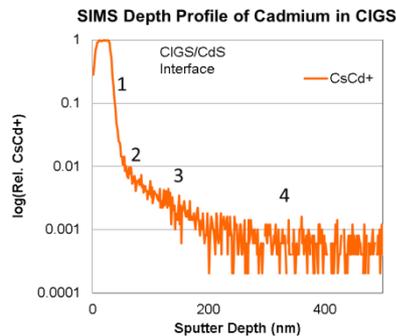
## Important properties of TCO for DH stability

- Thickness of the film, Sheet Rho
- Grain boundaries
- Bias conditions, (Processing parameters)
- Multi-layers of same or different films has profound effect on the stability of the TCO

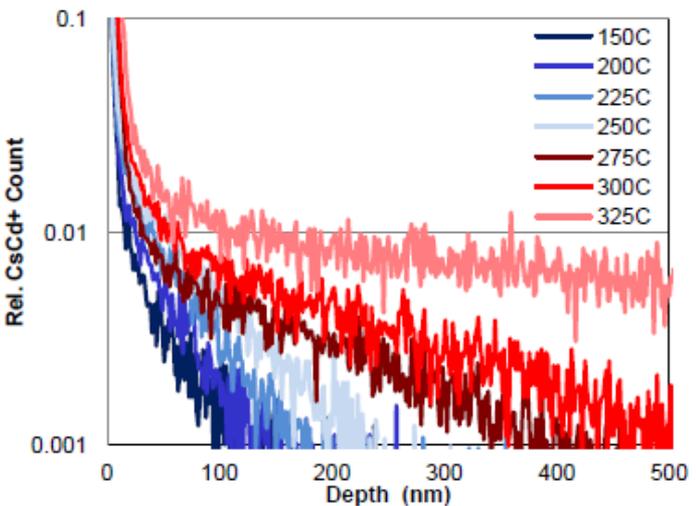
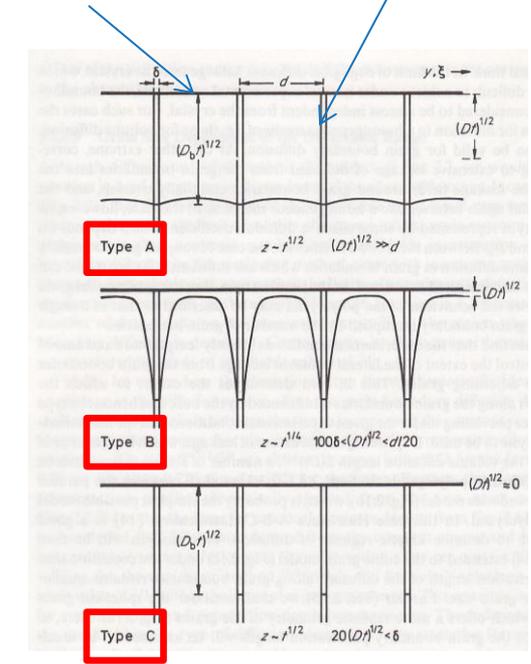
# Understand Long term reliability- CdS diffusion in CIGS failure mechanisms

- Failure physics correlated to mass transport kinetics
  - Diffusion via lattice (volume)
  - Diffusion via grain boundary

- SIMS analysis –
  - affected by Surface roughness
- Polish CIGS /Deposit CdS



Grain Boundary



- Region 1** – Volume diffusion from the surface
- Region 2** – Volume and grain boundary diffusion
- Region 3** – Grain boundary diffusion
- Region 4** – Background noise level

LaClaire's analysis

$$s\delta D_b = 1.32(D/t)^{1/2}(\partial \ln \bar{c} / \partial z^{6/5})^{-5/3}$$

$$\ln\left(\frac{D_b}{\sqrt{D}}\right) = \ln\left(\frac{D_{b0}}{\sqrt{D_0}}\right) + \frac{1}{T} \left( \frac{\frac{1}{2} \Delta E - \Delta E_b}{k} \right)$$

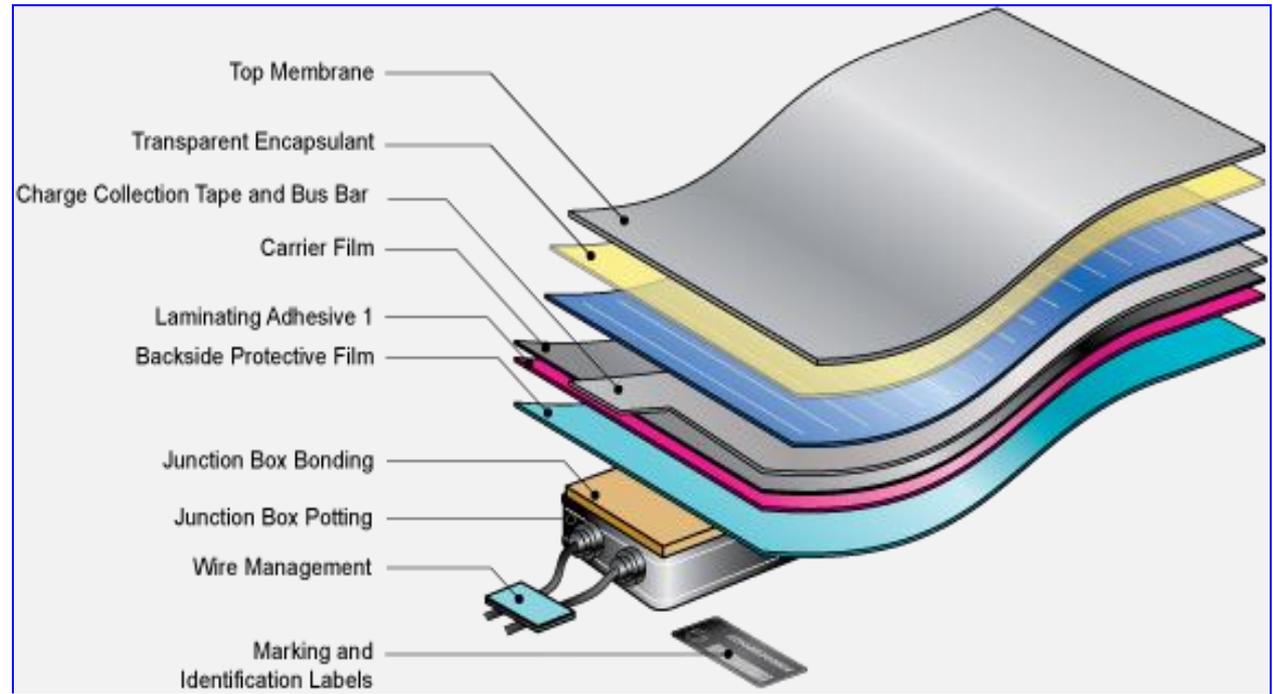
The activation energy for volume diffusion of cadmium in CIGS is ~1 eV [2]

Thus  $\Delta E_b$  is ~0.7 eV ; Equation necessarily suggests  $\Delta E_b > \frac{1}{2}\Delta E$



Module level reliability  
Field failures  
Indoor Accelerated Lifetime Tests (ALT's)  
Interconnect reliability  
Modeling

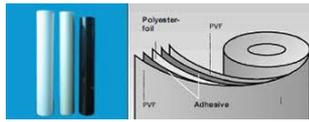
# CIGS Module (Rigid/Flexible)



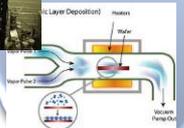
| Deposition method       | Company                              |
|-------------------------|--------------------------------------|
| Co-evaporation          | Würth, GSE, Ascent, Solibro          |
| Selenization            | Solar frontier, Avancis, STION, TSMC |
| Sputtering              | Miasole                              |
| Nanoparticle            | Nanosolar, ISET, Pioneer products    |
| Electroplating          | Solopower/NEXCIS                     |
| FASST and other process | Heliovolt                            |

Different ways of fabricating CIGS

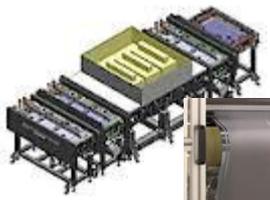
# Module manufacturing



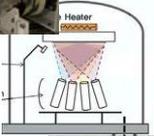
Encapsulation materials and back end process



Front Contact/Grids



Buffer Layer  
(Toxic / Non Toxic)



Back contact and CIGS Processes



Material Suppliers

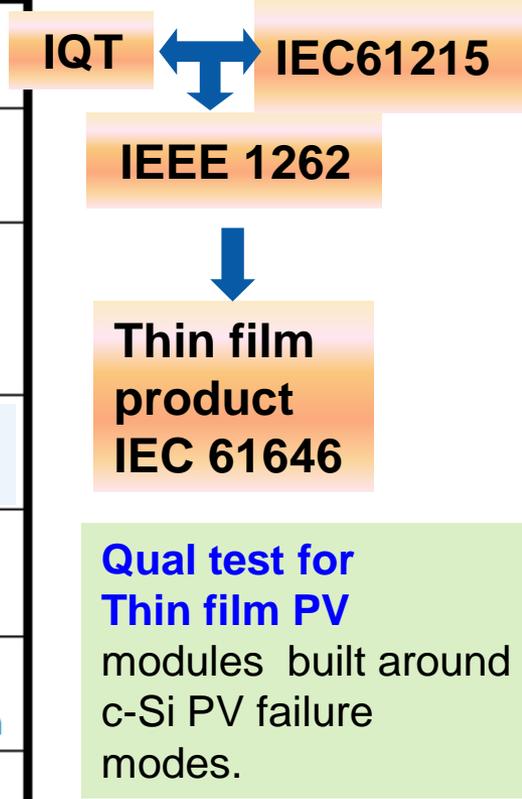


In the process of manufacturing a PV module- each and every layer can be processed in different ways-.Material and equipment suppliers come up with new products catering to different process steps. Combination of all these aspects makes the reliability of the product challenging.

# History of Qualification Tests – Certification Standards

c-Si      PVB encapsulants- with glass  
Corrosion of metallization      IEC 61215      EVA

| Test            | I<br>1975                          | II<br>1976                   | III<br>1977                  | IV<br>1978                   | V<br>1979                      |
|-----------------|------------------------------------|------------------------------|------------------------------|------------------------------|--------------------------------|
| Thermal Cycles  | 100<br>-40 to +90                  | 50<br>-40 to +90             | 50<br>-40 to +90             | 50<br>-40 to +90             | 200<br>-40 to +90              |
| Humidity        | 70C,90%<br>68 hrs                  | 5 cycles<br>40 to 23C<br>90% | 5 cycles<br>40 to 23C<br>90% | 5 cycles<br>54 to 23C<br>90% | 10 cycles<br>85 to -40C<br>85% |
| HOT SPOT        | Silicone encapsulant<br>- no glass | Modules in deserts           |                              |                              | 3 cells<br>100 hrs             |
| Mechanical Load |                                    | 100 cycles<br>2400 Pa        | 100 cycles<br>2400 Pa        | 10000<br>2400 Pa             | 10000<br>2400 Pa               |
| Hail            |                                    |                              |                              | 9 impacts<br>3/4" –45 mph    | 10 impacts<br>1" – 52 mph      |
| High Pot        |                                    | <15 µA<br>1500 V             | < 50 µA<br>1500 V            | < 50 µA<br>1500 V            | < 50 µA<br>2*Vs+1000           |



PVMRW2010-  
John Wohlgemuth

## Qualification testing is confused with reliability testing

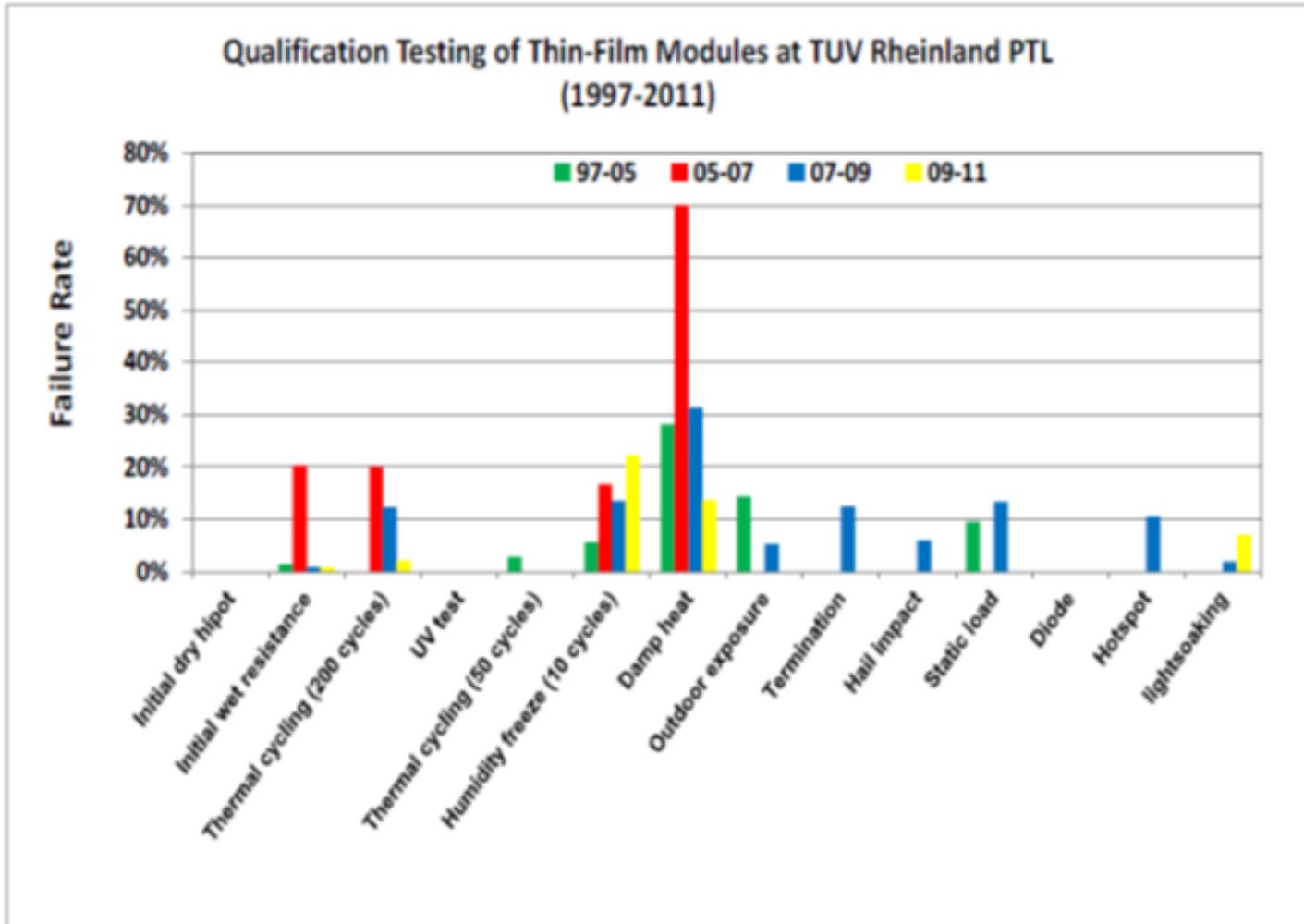
Incorporates pass/fail criteria- **DOES NOT PREDICT PRODUCT LIFE TIME**

Stress levels and durations-limited- to minimize time and cost

**Goal:** significant # of modules will pass the criteria- Production modules will be built the same way test modules are built.



# Where does the failure occur in TF-PV?



New generation modules ('05-'07)- DH failure rate 70%

## Lessons learnt

(07-09) :

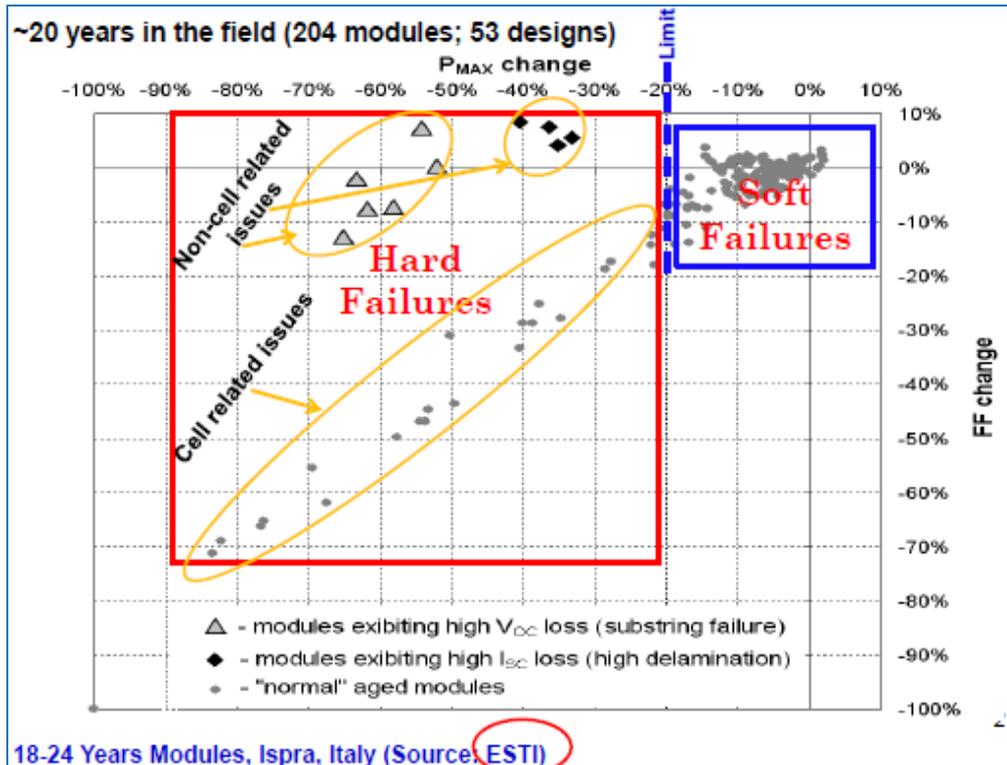
- Brought down the DH failure rate down to 30%
- New failure modes observed.

## Questions:

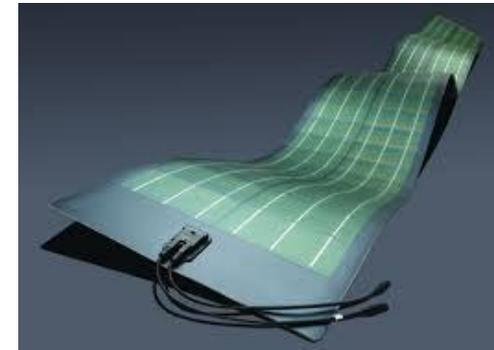
How do we replicate these failures in the lab?

# Design differences

Design differences in current CIGS module manufacturing approach



Design differences in modules can lead to different types of failures in the field:  
 ( Data from field : 203 modules and 53 designs)  
**Hard failures (-20% to -85%) Pmax change due to FF**  
 Substring failure: ( $V_{oc}$  loss)  
 Delamination ( $I_{sc}$  loss)  
 Cell related loss and non-cell related loss  
**Soft failures (10 to -20% ) Pmax change due to FF**  
 No dearth for interesting and useful topics to work on!



Tab and string



Wire method

CNSE : Roof top Array



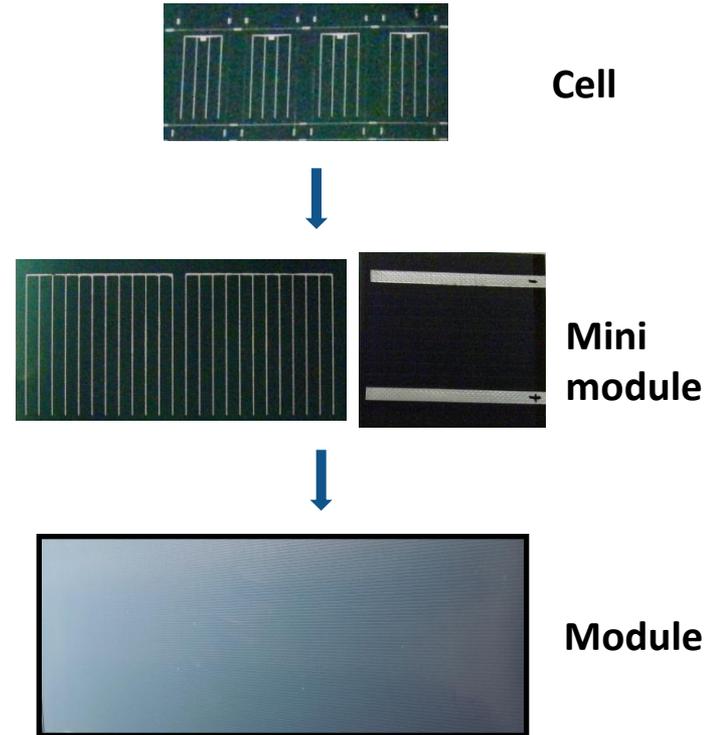
Monolithically integrated

# Indoor Accelerated Lifetime Tests

- Junction degradation
- Packaging
- Interconnect degradation
- Barrier layers

## Need to establish

- ❖ Standard structure for a failure mechanism.
- ❖ ALT's beyond normal acceleration-combinatorial tests
  - ❖ Chamber options((DH/Dry)- with Light/ HALT/ HASS)
- ❖ Protocols for measurements (Combinatorial/Stress order/ Load/In-situ/ **Normal Operating Cell Temperature (NOCT)/Standard Testing Conditions (STC)**)
- ❖ Protocols for combinatorial stress factors (RH, T, Bias, Mechanical) + Pre conditioning)



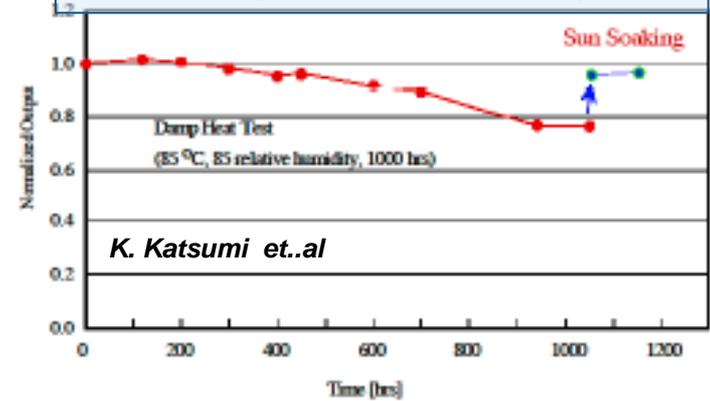
# Effect of light, temperature and moisture

Indoor: Light Soak after DH exposure for 1000hrs

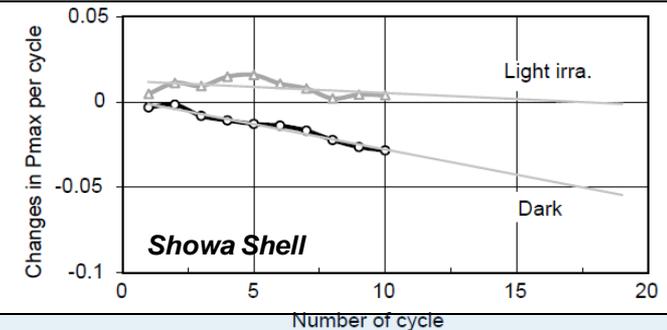
Outdoor: Enhancement in efficiency by outdoor light soaking for 3-4 hrs after fabrication

Probable reason: Changes in the buffer layer due to the presence of moisture and heat could be the reason for decreased and improved performance the efficiency- failure mechanisms worth investigating

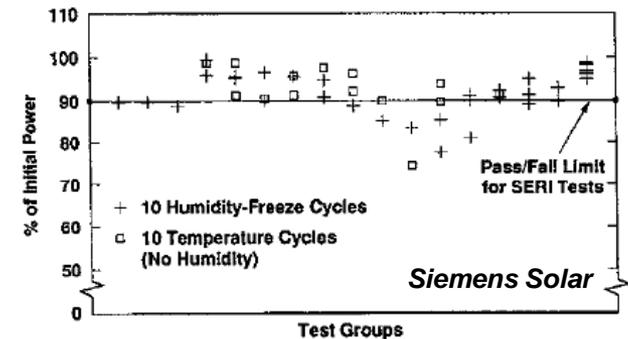
Effects of Light soak after DH exposure



Effects of light on modules in DH chamber



Effects of Temperature cycling / HF cycles



Indoor: DH exposure with and without light exposure

Degradation in the presence of light

is less than

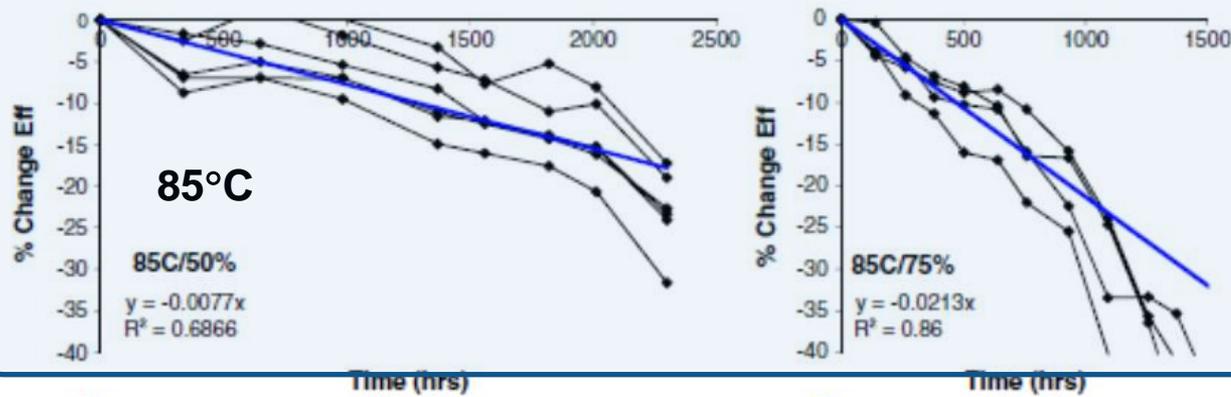
degradation in Dark -Damp heat

Humidity freeze and Temperature cycles with no humidity shows similar changes in performance.

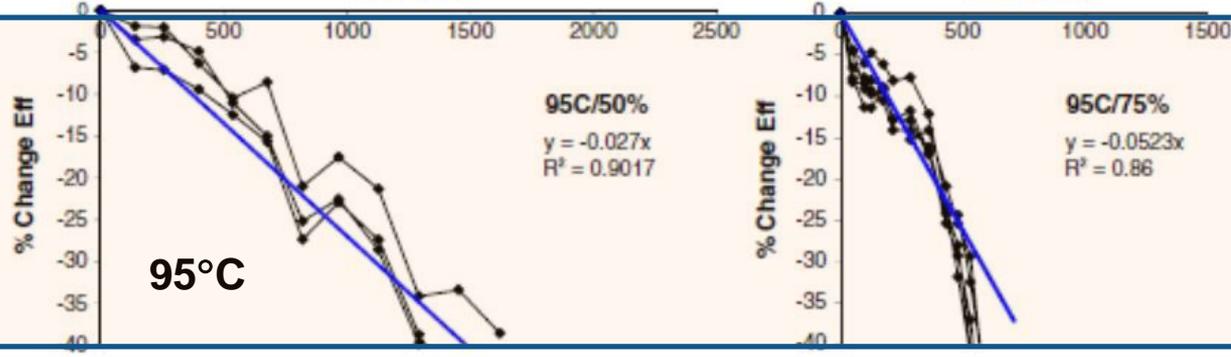
Future experiments

Isolate Temp. and Moisture and perform indoor tests with and without light to understand electrical performance and compare the results with outdoor performance

# Indoor ALT's – Stress conditions- Multiple failure modes



Temperature and Humidity effects



Combinations of different T and RH

Multiple failure modes



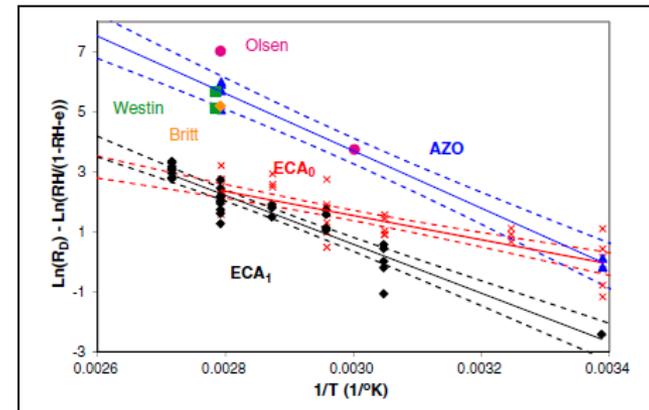
High temperature : CIGS failure

Low Temperatures : ECA dominated Failures



Need to interpolate the results to use condition

D.Coyle et.al PVMRW 2010

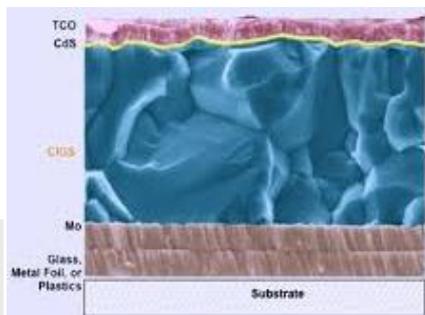


ACTURING CONSORTIUM



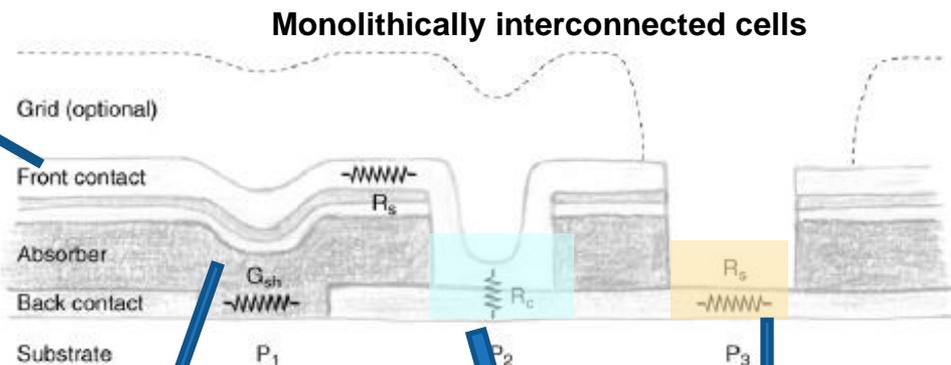
# Interconnect degradation Failure modes/mechanisms

CC of ZnO:Al decreases  
Affects FF ( high ohmic losses in Front contact)



ABSORBER

**J-V parameters**  
Voc , FF



Sheet resistance  
Mo-P3 scribe

Performance loss

**Resistance**

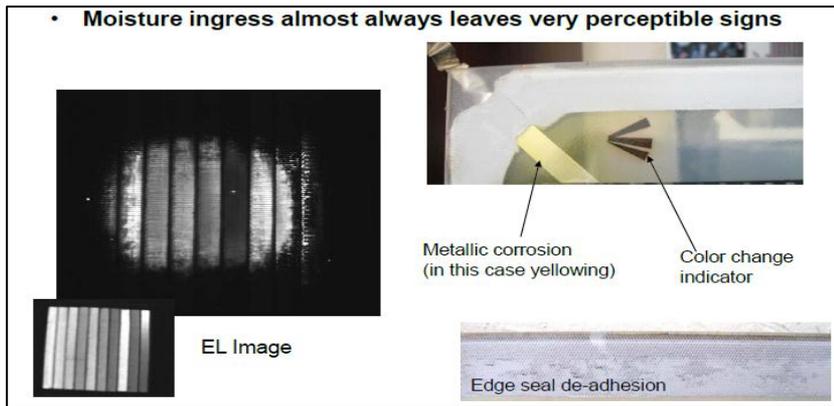
P2 contact resistance  
(Mo and ZnO:Al)

CIGS absorber

Enhanced recombination-due to defect density in  
1)bulk or  
2)at grain boundaries of CIGS  
& Shift in the Fermi level CIGS/CdS interface

| Parameter  | As-grown       | 500 h          | 1000 h         |
|--|----------------|----------------|----------------|
| Open circuit voltage (mV)                                  | ~ 640          | ~ 540          | ~ 510          |
| Fill factor (%)  | 75             | 62             | 58             |
| ZnO:Al front contact sheet resistance ( $\Omega/\square$ ) | 10             | 20             | 30             |
| Mo back contact sheet resistance ( $\Omega/\square$ )      | 0.5            | 0.7            | 1              |
| CIGS absorber resistivity ( $\Omega\text{cm}$ )            | 20             | 10             | 10             |
| P <sub>2</sub> contact resistance ( $\Omega\text{cm}^2$ )  | $\sim 10^{-4}$ | $\sim 10^{-3}$ | $\sim 10^{-3}$ |
| Mo sheet resistance in P <sub>3</sub> ( $\Omega/\square$ ) | 0.5            | 100            | $\infty$       |

# Finger prints-outdoor metrology & modeling

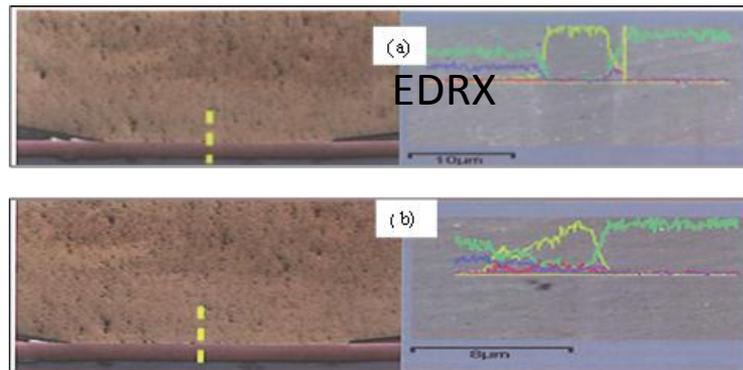
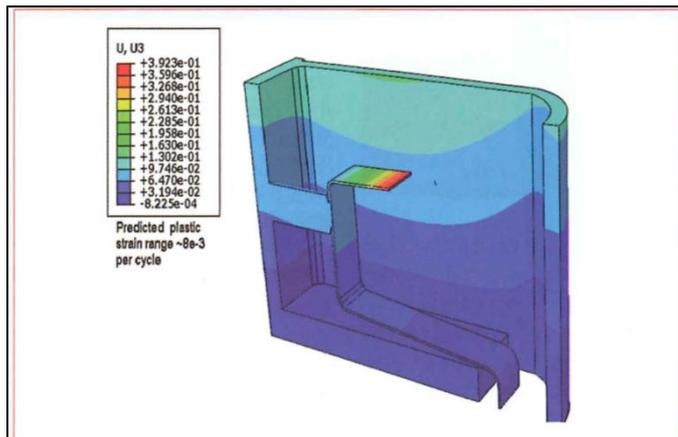


Common Failure Modes for Thin-Film Modules and Considerations Toward Hardening CIGS Cells to Moisture -A “Suggested” Topic Kent Whitfield, Dir. Reliability

← Outdoor metrology Finger prints

## Failure mode and effect analysis Junction box, potting and busbar – stress/strain amplitude

Establishing a reliability methodology for thermal- cycle failure modes for CIGS modules-Kent Whitfield et.al.



Correlation of metalling mixing corresponds to bond strength at the weld.  
a)Sharp b)smooth transitions in metal mixing

Welded joints analyzed using EDRX measurements .

“Deformation of the top bend is primarily driven by large expansion and contraction of the potting compound coupled with volumetric constraint offered by junction-box enclosure”

# Opportunities moving forward in CIGS reliability

- Standards
  - Develop standards ( light soak, Indoor tests- Find acceleration factors)
  - Develop standard test structures for analyzing different failure mechanisms
- Indoor ALT's -Identify Failure modes and mechanisms
  - Junction degradation ( Relate Cell- Module reliability)
  - Interconnect ( monolithic/cell based)
  - Packaging (Edge seal, EVA- Moisture ingress, PID)
  - Develop accelerated model
- Modeling
  - Thermal cycling, Mechanical failures
- Outdoor field performance :
  - Systematic metrology to understand field failures
  - Outdoor test individual modules and string outdoors in different climates and compare with field data
- Relate Indoor testing – Outdoor testing- bridge the gap.
- Develop a web based reliability- bankability comprehensive database

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